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Signature

Date

287> /SB/21 (08-00)

PTO/SB/21 (08-00) Approved for use through 10/31/02. OMB 0651-0031 Please type a plus sign (+) inside this box TM U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number. 10/058,263 **Application Number TRANSMITTAL** January 25, 2002 Filing Date Milad F. Tabet **FORM** First Inventor 4087 Confirmation No. **Group Art Unit** 2877 all correspondence after initial filing) Roy M. Punnoose **Examiner Name** NAN028 US Total Number Of Pages In This Submission 7 Attorney Docket No. **ENCLOSURES** (check all that apply) Fee Transmittal Form **Assignment Papers** After Allowance Communication to (1 page in duplicate) (for an Application) Group Fee Attached -- Credit Appeal Communication to Board of Drawing(s) Card Payment Form (1 pg) Appeals and Interferences Appeal Communication to Group Amendment / Reply (6 pages) Licensing-related Papers (Appeal Notice, Brief, Reply Brief) **Proprietary Information** After Final Petition Petition to Convert to a **Status Letter** Affidavits/declarations Provisional Application Power of Attorney, Revocation of Other Enclosure(s) (please identify Previous Powers; And Statement **Extension of Time Request** below): Under 37 CFR 3.73(b) Terminal Disclaimer RETURN RECEIPT POSTCARD **Express Abandonment Request** Request for Refund CD, Number of CD(s)____ Information Disclosure Statement Certified Copy of Priority Document(s) Remarks This is a Response to Missing Parts/ Incomplete Application under 37 CFR 1.52 or 1.53 Copy of Notice To File Missing Parts (2 pages) SIGNATURE OF APPLICANT, ATTORNEY OR AGENT Firm Michael J. Halbert (Reg. No. 40,633) or Silicon Valley Patent Group LLP Individual Name 2350 Mission College Boulevard, Suite 360

EXPRESS MAIL LABEL NO. EV 450 194 565 US

Santa Clara, California 95054

September 14, 2004



ventors:

Milad F. Tabet

Assignee:

Nanometrics Incorporated

Title:

Method of Measuring Small Pads on a Substrate

Serial No.:

10/058,263

Filing Date:

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Examiner:

Roy M. Punnoose

Group Art Unit:

2877

Docket No.:

NAN028 US

Confirmation No.:

4087

Santa Clara, California September 14, 2004

Mail Stop Amendment Commissioner For Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Dear Sir:

This Response to Office Action is responsive to the June 17, 2004, Office Action, which has a statutorily shortened period for response that ends September 17, 2004. Please enter the following amendments before taking action on the merits of the above-referenced application.

SILICON VALLEY PATENT GROUP I.LP

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